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|-----------------------------------|--|----------------------------|--|-------------|
| <b>Notice of References Cited</b> |  | Application/Control No.    | Applicant(s)/Patent Under Reexamination<br>JARVIS ET AL. |             |
|                                   |  | Examiner<br>Irina S. Zemel | Art Unit<br>1796   | Page 1 of 1 |

**U.S. PATENT DOCUMENTS**

| * | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Name          | Classification |
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| B | US-  |                 |               |                |
| C | US-  |                 |               |                |
| D | US-  |                 |               |                |
| E | US-  |                 |               |                |
| F | US-  |                 |               |                |
| G | US-  |                 |               |                |
| H | US-  |                 |               |                |
| I | US-  |                 |               |                |
| J | US-  |                 |               |                |
| K | US-  |                 |               |                |
| L | US-  |                 |               |                |
| M | US-  |                 |               |                |

**FOREIGN PATENT DOCUMENTS**

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| O |  |                 |         |      |                |
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**NON-PATENT DOCUMENTS**

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| V |   |
| W |   |
| X |   |

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.